

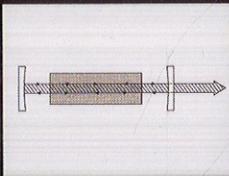
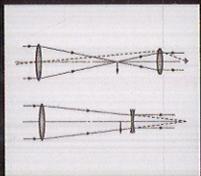
Third Edition

Sponsored by the Optical Society of America

# HANDBOOK OF OPTICS

## **Volume II**

*Design, Fabrication, and Testing; Sources  
and Detectors; Radiometry and Photometry*



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